

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Naoya SASHIDA et al.

Serial Number: 09/321,605

Filed: May 28, 1999

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING CAPACITOR (as amended)**



Group Art Unit: 2813

Examiner: **Chen, J.**

**AMENDMENT**

Director of Patents and Trademarks  
Washington, D.C. 20231

July 12, 2000

Dear Sir:

In response to the Office Action dated April 12, 2000, please reconsider the above-identified application amended as follows:

**IN THE TITLE:**

Please change the title from "SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME" to read --METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING CAPACITOR--.

RECEIVED  
JUL 17 2000  
TECHNOLOGY CENTER 2800

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